

Title (en)

EDGE ROUNDED FIELD EFFECT TRANSISTORS AND METHODS OF MANUFACTURING

Title (de)

ABGERUNDETE FELDEFFEKTTRANSISTOREN UND HERSTELLUNGSVERFAHREN

Title (fr)

TRANSISTORS À EFFET DE CHAMP À BORDS ARRONDIS ET LEURS PROCÉDÉS DE FABRICATION

Publication

EP 2656381 A4 20171101 (EN)

Application

EP 11850857 A 20111219

Priority

- US 97375610 A 20101220
- US 2011065930 W 20111219

Abstract (en)

[origin: US2012153377A1] Embodiments of the present technology are directed toward gate sidewall engineering of field effect transistors. The techniques include formation of a blocking dielectric region and nitridation of a surface thereof. After nitridation of the blocking dielectric region, a gate region is formed thereon and the sidewalls of the gate region are oxidized to round off gate sharp corners and reduce the electrical field at the gate corners.

IPC 8 full level

H01L 29/78 (2006.01); **H01L 29/66** (2006.01)

CPC (source: CN EP KR US)

H01L 21/28202 (2013.01 - CN EP KR US); **H01L 29/40117** (2019.07 - CN EP US); **H01L 29/4234** (2013.01 - KR);
H01L 29/518 (2013.01 - CN EP KR US); **H10B 43/30** (2023.02 - CN EP KR US)

Citation (search report)

- No further relevant documents disclosed
- See references of WO 2012087978A2

Designated contracting state (EPC)

AL AT BE BG CH CY CZ DE DK EE ES FI FR GB GR HR HU IE IS IT LI LT LU LV MC MK MT NL NO PL PT RO RS SE SI SK SM TR

DOCDB simple family (publication)

US 2012153377 A1 20120621; US 9412598 B2 20160809; CN 103380488 A 20131030; CN 103380488 B 20170208;
CN 106847686 A 20170613; CN 106847686 B 20200424; EP 2656381 A2 20131030; EP 2656381 A4 20171101; JP 2013546206 A 20131226;
JP 2015173298 A 20151001; JP 5774720 B2 20150909; JP 6039757 B2 20161207; KR 101983682 B1 20190529; KR 20140003492 A 20140109;
WO 2012087978 A2 20120628; WO 2012087978 A3 20120927

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